

# Living up to Life

## EM Sample Preparation

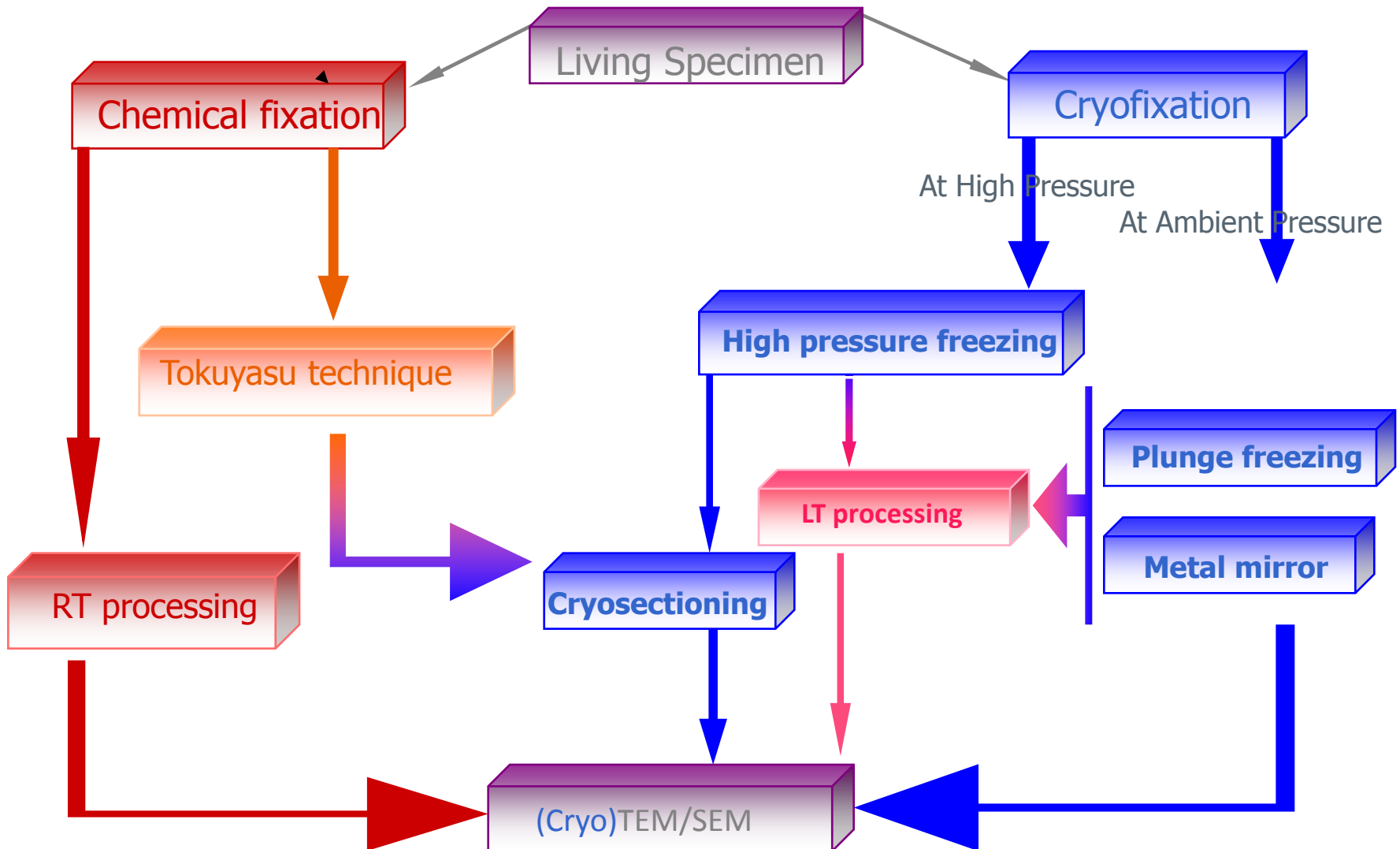
Techniques and pathways

By Leica Nanotechnology

Santiago Sevillano

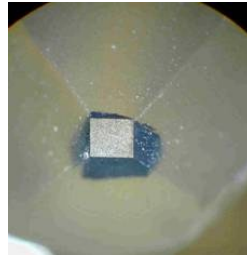
## SOME TECHNIQUES....

ULTRAMICROTOMY / CRYO-ULTRAMICROTOMY <b>LEICA UC6-FC6</b>	TRIMMING/ KNIFE-MAKER <b>LEICA KMR2</b>	CRITICAL POINT DRYING <b>IN BRAGA?</b>
CONTRASTING /LABELLING	PROCESSING/ DEHIDRATATION CHEMICAL FIXATION RESIN EMBEDDING	COATING <b>HIGH VACUUM            EVAPORATOR POLARON            CRESSINGTON SPUTTER</b>
FREEZE ETCHING / FREEZE FRACTURE	CRYO-TRANSFER	FREEZE SUBSTITUTION
CRYO-FIXATION HIGH PRESSURE FREEZING	CRYO-FIXATION BARE GRID TECHNIQUE PIN IMMERSION	CRYO-FIXATION SELF PRESSURE FREEZING
TARGET PREPARTION (CUTTING, MILLING, SAWING, POLISHING, GRINDING) <b>IN MINHO?</b>	ION BEAM CUTTING	ION MILLING SYSTEM



**EXAMPLE:** Workflow of Room Temperature Specimen Preparation for TEM

**Fast  
AMW**



**AC20**



**TP  
Standard**

**KMR3**

**Trim2**

**UC7**

**IGL**

**Tissue  
Processing**

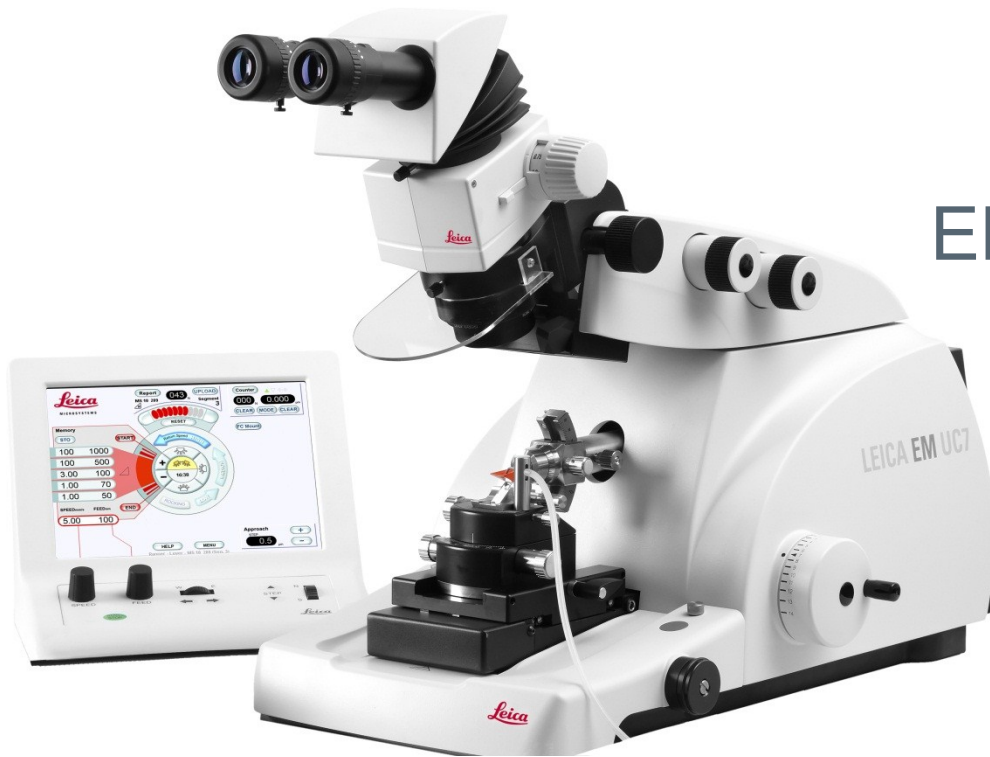
**Knifemaking**

**Trimming**

**Ultrathin  
sectioning**

**Contrasting or  
Immunogold  
labelling**

# EM UC7: Ultramicrotome



# EM KMR3 : Knifemaker



# The Leica Ultracut EM UC7

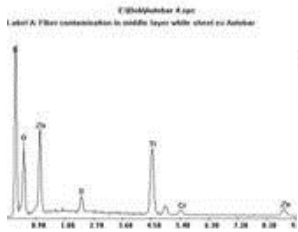
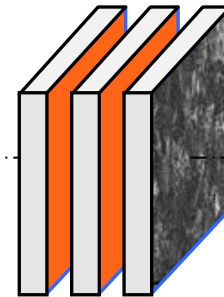
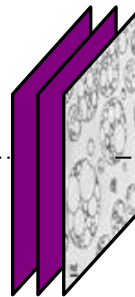
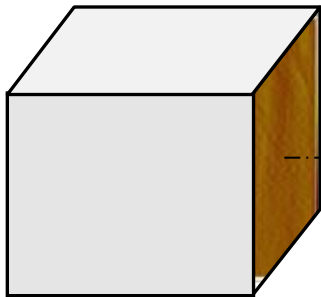
- is used for ultrathin sectioning for TEM
- Surface planing of AFM and **SEM samples**. Industrial material manufacturers and research (polymer, rubber, and materials), as well as cosmetic samples.
- Semithin sections for LM and FT-IR
- 3D reconstruction (tomography, serial sectioning)

# Leica EM UC7 application

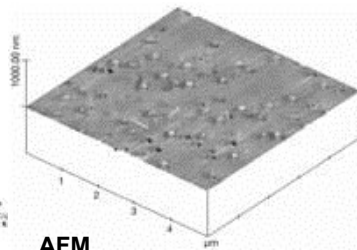
**Sample surface:**  
SEM, AFM, SIMS

**Ultra thin section:**  
( $< 200\text{nm}$ ) TEM

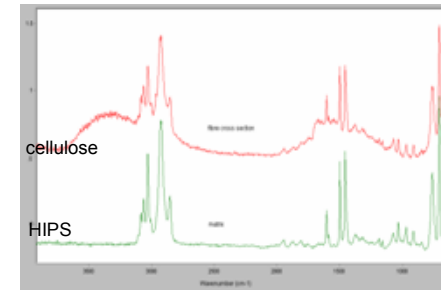
**Thin section:**  
( $0.2\text{-}15\mu\text{m}$ ) LM, FT-IR



EDX



AFM



FT-IR

# Trimming and /or Targeting



**TRIM2**

## Why using a trimming tool?

- 1) Save time and money
- 2) Save diamond/glass knives



# Synergies - Room temperature SEM workflow

Tissue Processing –  
Leica EM TP



Automated tissue processing  
for fixation and dehydration.

Critical Point Drying –  
Leica EM CPD300



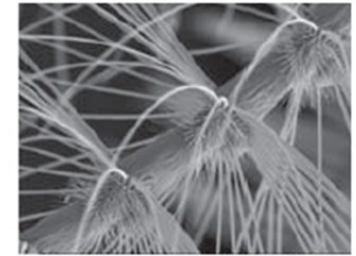
Automated critical point drying  
for extremely well preserved  
sample structures.

Coating –  
Leica EM ACE200 and ACE600



Automated coating for reproducible,  
thin and conductive layers.

Imaging and analysis



Antenna of male mosquito  
(Gold sputter coating), SEM.

H<sub>2</sub>O concentration

Liquid CO<sub>2</sub>  
concentration

Carbon, Gold,  
Platinum...

Ethanol, Acetone  
concentration



Material Research  
Samples

# Tissue Processing



**TP**



**AMW**

■ **WHY ? SAFETY REASONS !!!**

1) **Automatic processing of tissue:**

Minimizes contact with hazardous reagents (eg. Uranyl, Osmiun or Glutaraldehyde during the CHEMICAL FIXATION).

2) **Closed processing chamber with fume extraction system**

# Critical Point Drying

**CPD300**



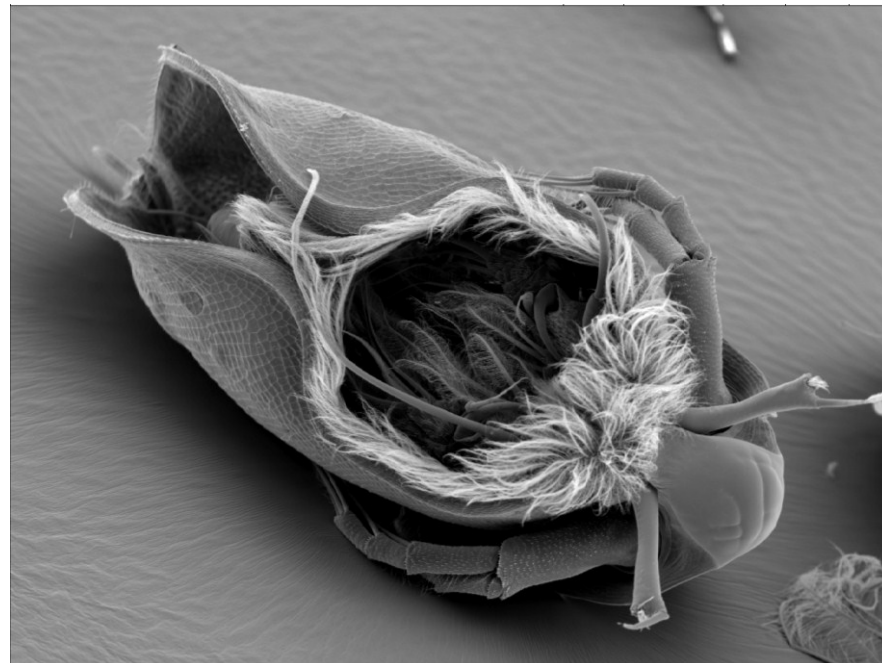
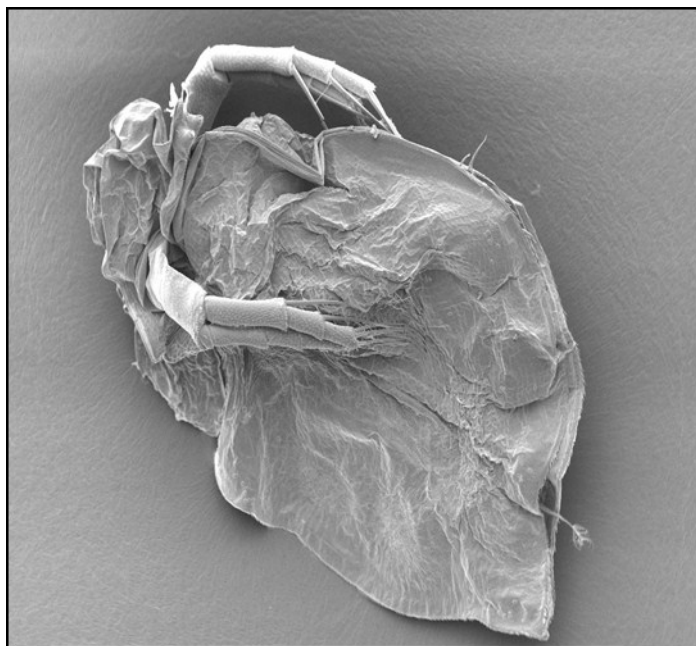
**Cells**  
**Insects**  
**Tissues**  
**Wafers**  
**Etc...**

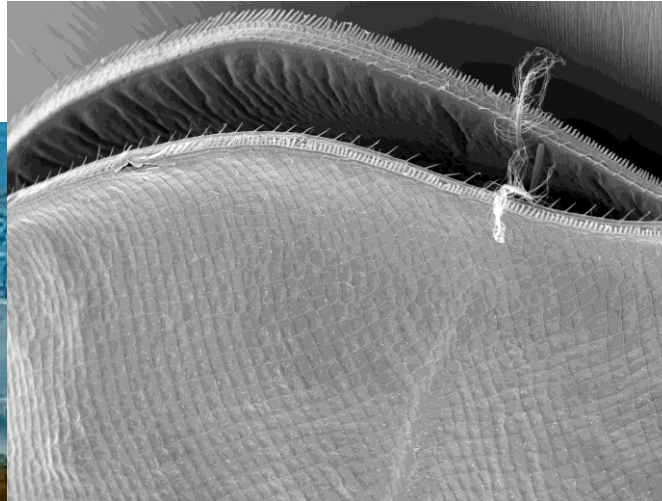
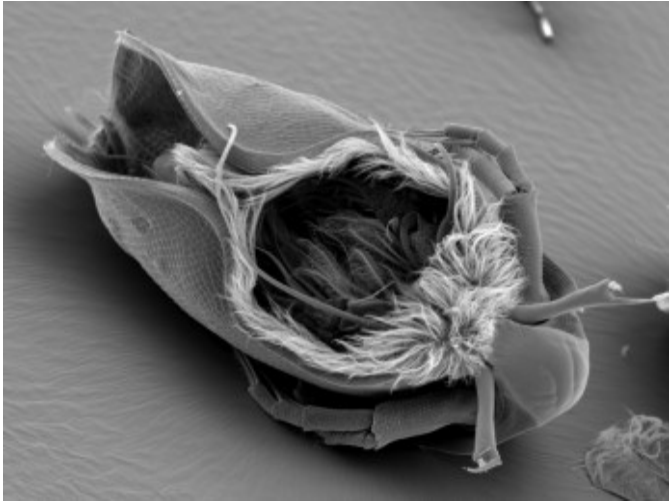
**Why ?**

**Surface Tension of Water Damages Sample, but not CO<sub>2</sub>**

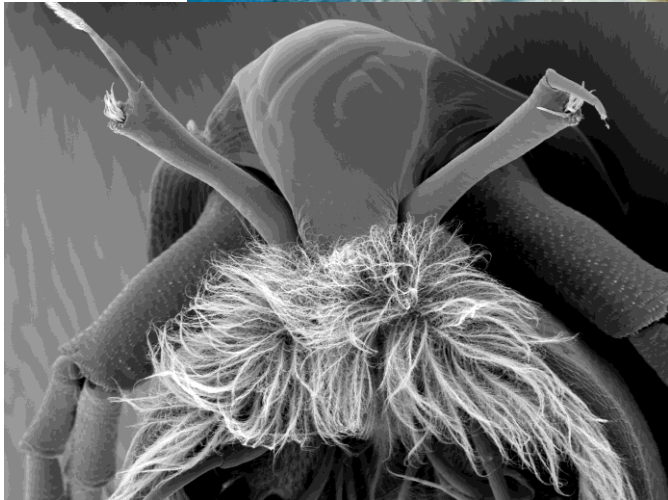
**You should avoid water in the EM column**

And the result is....



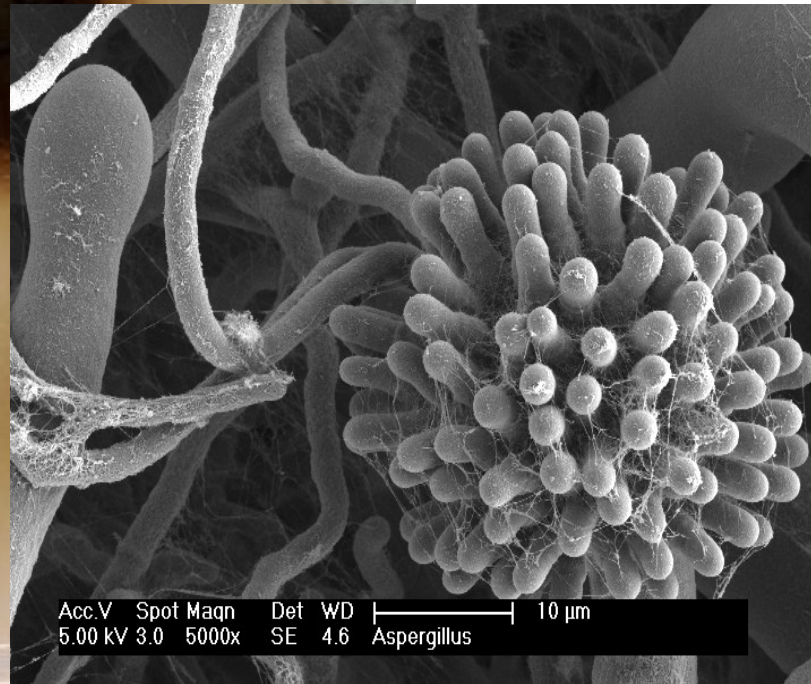


Water Flea (*Daphnia sp.*)



Courtesy of D.  
Gruber, University  
of Vienna, Austria





labs.com

Mold & Bacteria Laboratories

W. Müller, University of Utrecht, Netherlands

# Coating



**ACE200**



**ACE600**



**Cryo-ACE600**

**At SEMAT:  
Evaporator Polaron  
Sputter Cressington**

# Why do we coat ?

## SEM

- Reduce charging, inhibits charging
- Improves the secondary electron signal
- Higher electron yield from specimen surface
- Prevent specimen thermal damage

## TEM

- Support films for TEM-grids (carbon on formvar)
- Generate contrast on thin samples (low-angle shadowing)
- Freeze-fracture replica technique

Or, to produce conductive layers in Micro-electronics research.



# Different Coatings

- **WHY METAL SPUTTERING COATING?**
- Chemically inert, does not react with specimens or acids
- Stable in the electron beam
- Transparent to the electron beam (does not create contrast!)
- Conductive - reduces charging
- **WHY CARBON COATING?**
- Reduce charging
- Localize secondary electron (SE) and back-scattered electron (BSE) signal to the surface in SEM
- Reduce heating of non-conductive specimens to increase potential exposure time to the electron beam
- Reveal topography with shadowing (TEM or SEM)



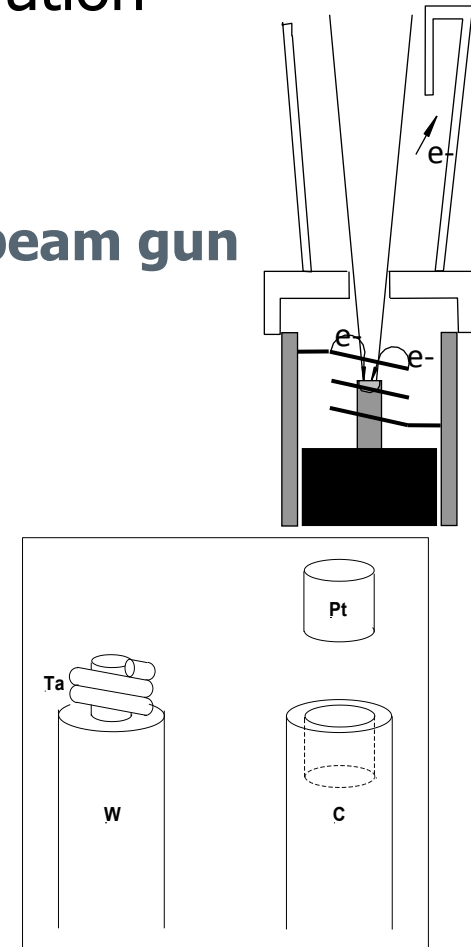
## Other techniques in your coater:

- **Sputtering metals** like gold, gold/palladium, silver, platinum etc... and additionally to LowVac, HigVac sputtering for materials like Aluminum, Chromium, Iridium, Molybdenum, Titanium Tungsten etc.
- **Conductive carbon films** for X-ray analyses, grids and backing of collodion and formvar films for biological EM via carbon thread /rod evaporation
- **Thermal resistance evaporation of metal and carbon.**
- **e-beam evaporation.** The finest layers, either carbon or metals.
- **Freeze drying, freeze etching, in combination with a VCT100:** Freeze fracturing **double replica**, cryo-transfer.

## Metal coating: Electron beam evaporation

### Evaporation of metals using the electron beam gun

- For materials with high melting point
- For very fine grained layers (W, Ta/W, Cr, Pt/C)
- Shadowing
- Homogeneous layers with DARS (Double Axis Rotary Shadowing)
- **Low heat transfer to specimen**
- **No charged particles to your sample**



## Coating quality depends on:

- Coating technique
- **Layer thickness**
- **Coating material**
- **Vacuum conditions**
- Specimen temperature
- The specimen itself (“decoration effects”)
- Effects after coating

## **Coating quality - Specimen temperature**

### **WHY CRYO-COATING ???**

- Reorganization of the coating material depends on the surface temperature.
- Colder temperature reduces mobility of the coating material causing:
  - Smaller distance between grains
  - Finer structure

# Synergies - Cryo SEM workflow

High Pressure Freezing –  
Leica EM HPM100, Leica EM PACT2



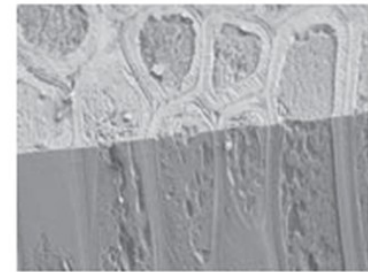
Cryo Ultramicrotomy –  
Leica EM UC7 with EM FC7



Coating –  
Leica EM ACE600 cryo outfit



Imaging and analysis



Superior cryo fixation to observe aqueous biological and industrial samples near to native state.

High quality ultrathin sectioning/planning for light, electron, and atomic force microscopy examination.

High vacuum coating in conjunction Leica EM VCT100 (vacuum cryo transfer) system for the finest metal and carbon layers.

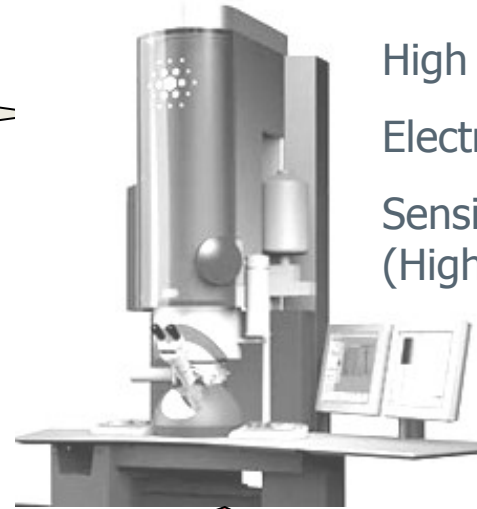
Mouse kidney (Platinum cryo-sputter coating), Cryo SEM.

## Biology

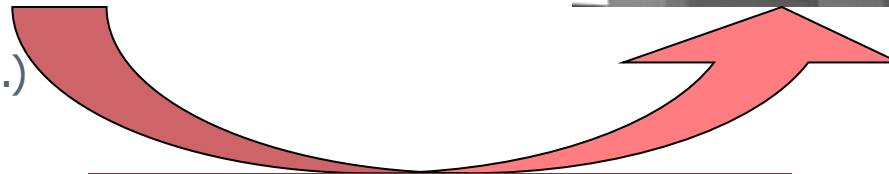
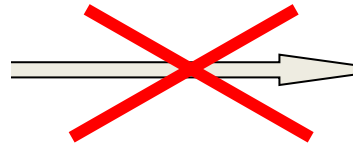


Soft and "Large"  
Aqueous/hydrated  
Light elements  
(C, O, H, N, S, P etc.)

## Electron microscope

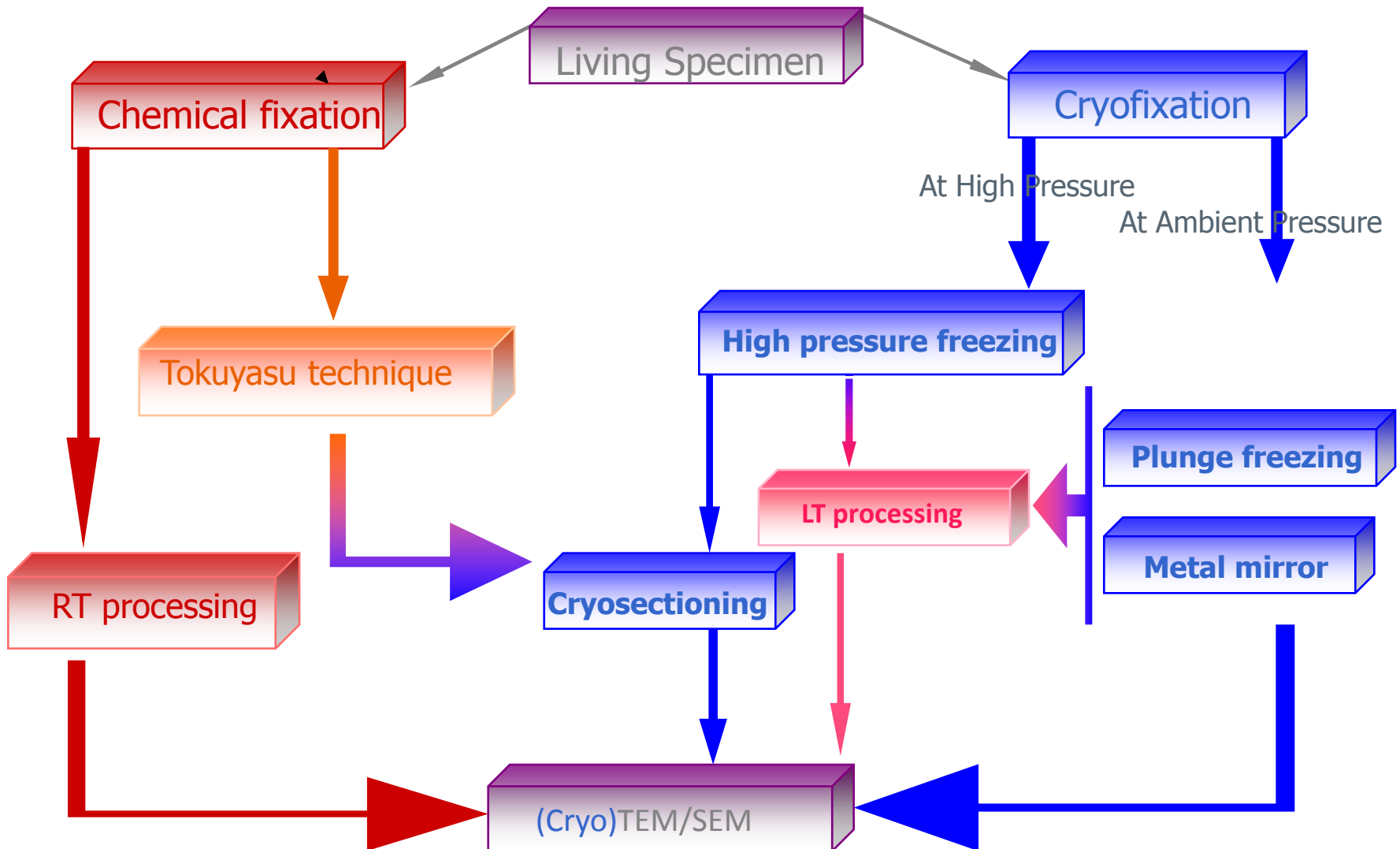


High vacuum  
Electron beam  
Sensitive to vibration  
(High magnifications)



**Any treatment induces  
changes in the specimen**

Contrast





# Why cryofixation?

- The cellular constituent is rapidly immobilized
- Cryofixation is a physical fixation of all cellular components simultaneously
- Enzymes and antigens are not denatured (antigenicity)
- Cells retained in their 'native' state
- The physical properties of a frozen sample allow cryo-sectioning without any additional support by embedding medium (CEMOVIS).

# Why High Pressure Freezing?

- No changes in the physical equilibrium because of fast and precise correlation between pressure and temperature
- No cryo-protection needed, so no alteration of the cellular processes
- Vitrification of sample thickness up to 200  $\mu\text{m}$



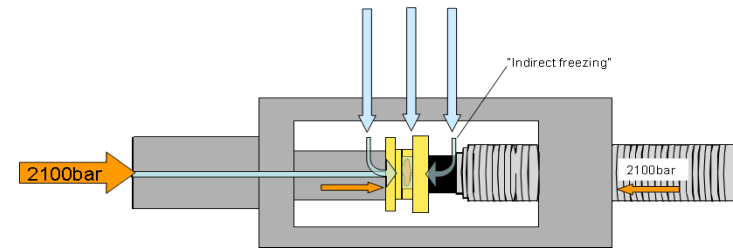
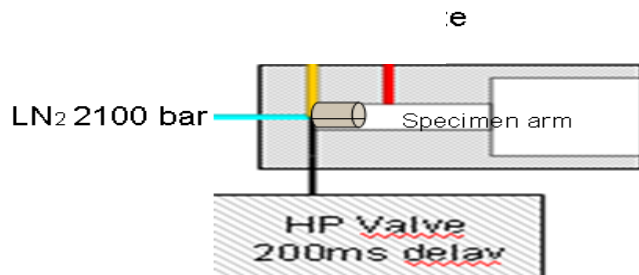
HPM100

High pressure freezing



HPACT2

LN<sub>2</sub> 10bar



- LN2 at 2100bar used for pressure build-up AND cooling
- Alcohol is synchronizing pressure build-up and cooling
- Pressure is the same everywhere

- Pressure build-up and cooling separated
- LN2 at 10 bar used for cooling only
- Pressure transferred only to specimen (2100bar) by filler

# Cryo-fixation

## Plunge Freezing and Metal Mirror



In biological research, virology, protein crystallography, pharmaceutical labs, cosmetic companies and paint research.

- **Process Automation**
  - Automatic blotting with optional sensor control
  - Controllable ethane container temperature

Reproducibility with high sample quality

# Leica EM FC7

- Three different cryo-condition modes:
  - standard mode
  - high gas-flow (to reduce ice contaminations)
  - wet sectioning (for polymer sectioning at wet condition using DMSO), wide range of different temperature settings of knife / specimen and gas (-40°C to -160°C)

# SPECIMEN MOUNTING AND TRANSFER

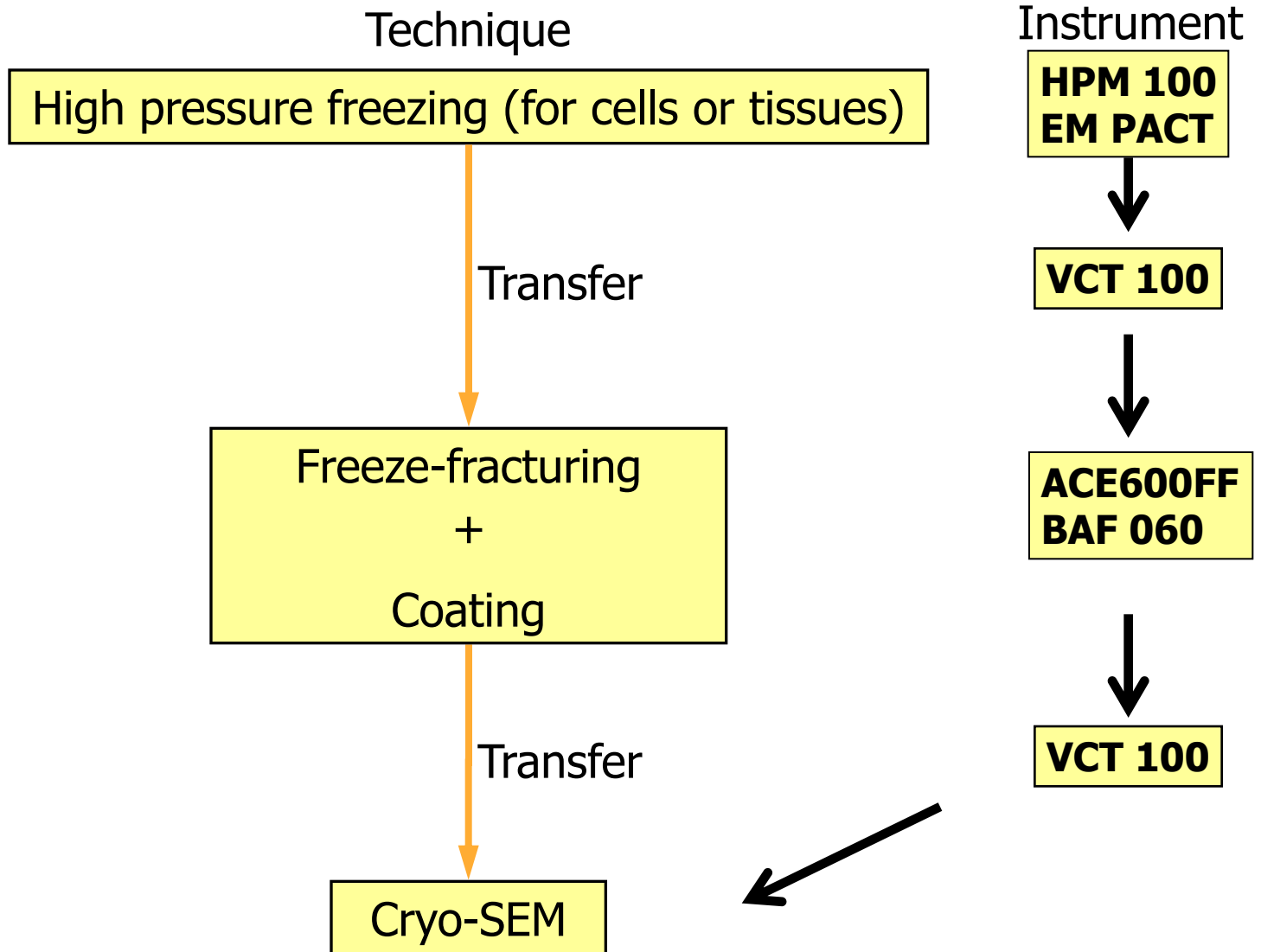
## Why? How could I transfer my sample?



**SHUTTLE**

**LOADING STATION**



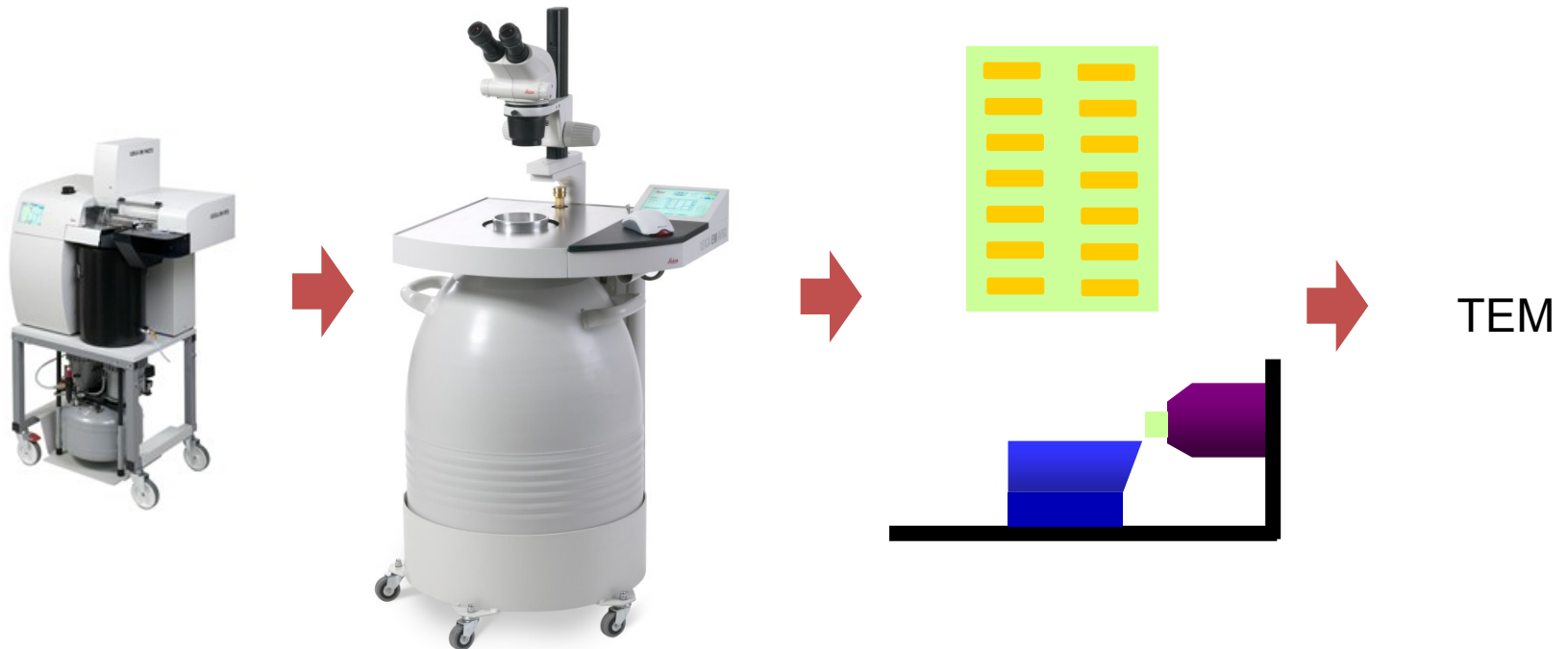


## VCT 100 - HIGH VACUUM CRYO TRANSFER TO SEM





# Pathway with Freeze Substitution



Dehydration of a cryofixed specimen by exchange of ice with an organic solvent

Freeze substitution is a link between cryofixation and room temperature TEM observation.

# Why Freeze Substitution?

- Enables sectioning at room temperature
- Avoids artifacts produced by conventional room temperature procedures
- Preserves **antigenicity**

High Pressure Freezing



(1)



Freeze substitution  
LT embedding



TEM

Contrasting



(EM AC20)

Sectioning



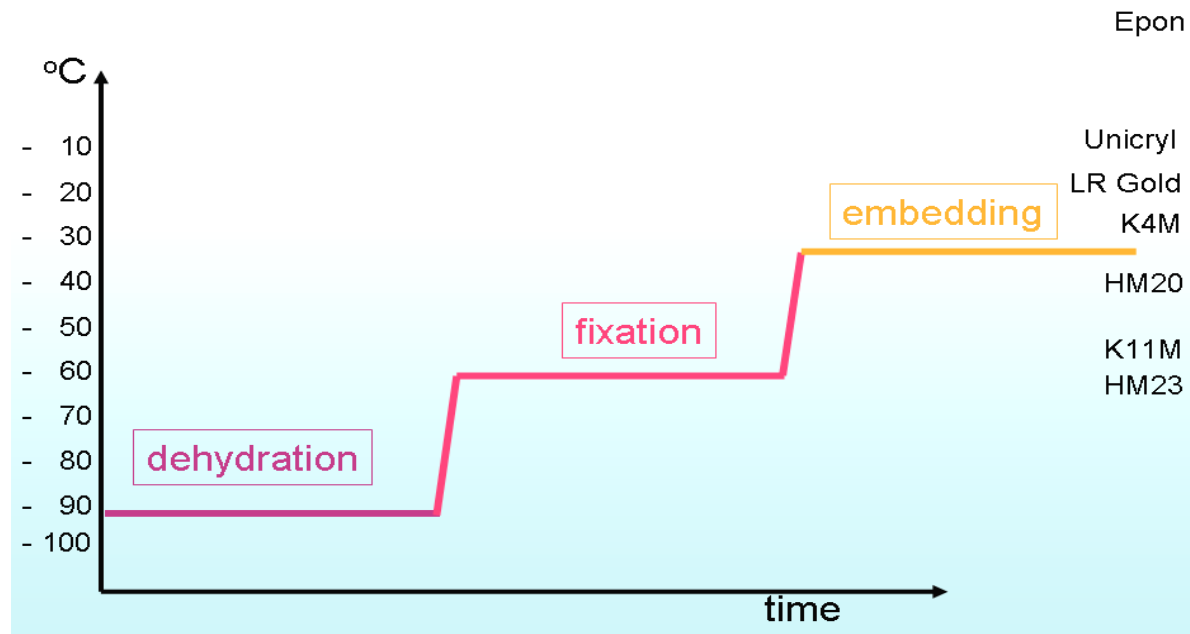
Trimming



(EM TRIM2)

# Freeze Substitution

- Minimized aggregation and redistribution of diffusible elements
- Fixatives are uniformly distributed throughout the sample



*Cryotechniques in Biological Electron Microscopy, 1987, Steinbrecht RA, Zierold K)*

# FSP

## Freeze Substitution Processor for EM AFS2

- Automatic reagent handling
- Special embedding moulds for
  - FS of high pressure frozen samples
  - PLT samples

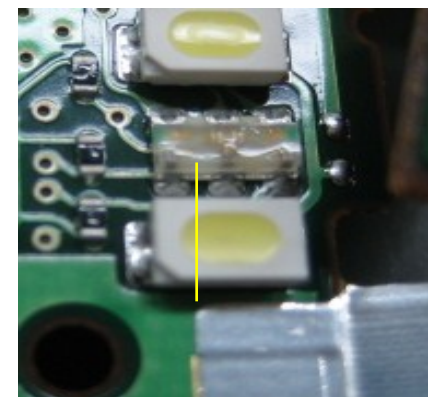
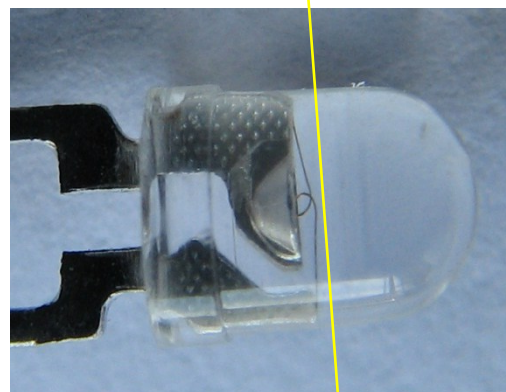
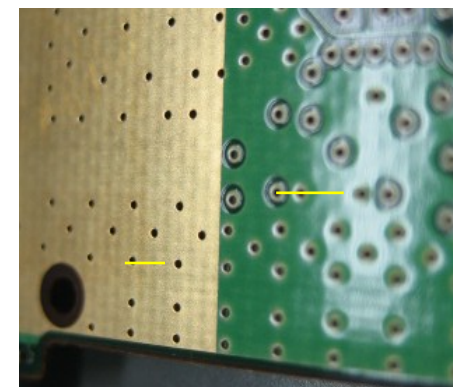
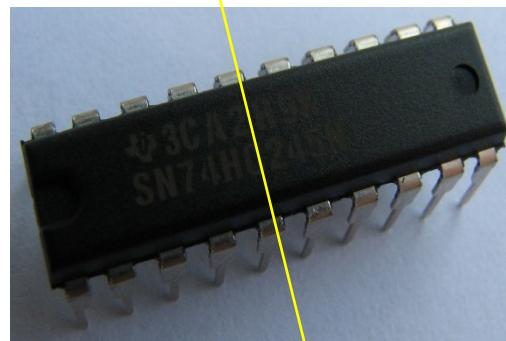
**“Load and Leave”**



# MATERIAL SCIENCES

# EM TXP

Target Surfacing Device for SEM, LM, TEM



- For site specific cross sections (target preparation)
  - Surfacing of small samples
  - Pre-preparation prior to ion beam polishing (SEM)
  - Pre-preparation prior to ion beam thinning (TEM)
  - Pre-preparation prior to ion beam slope cutting (SEM)
  - Pre-preparation prior to ultramicrotomy (SEM, TEM) **TRIMMING**
- Microelectronic market
  - Watch industry
  - Material reseach (Nano technology)





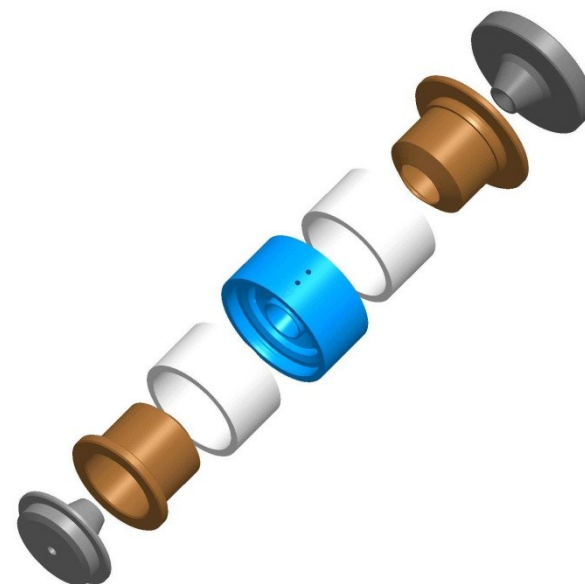
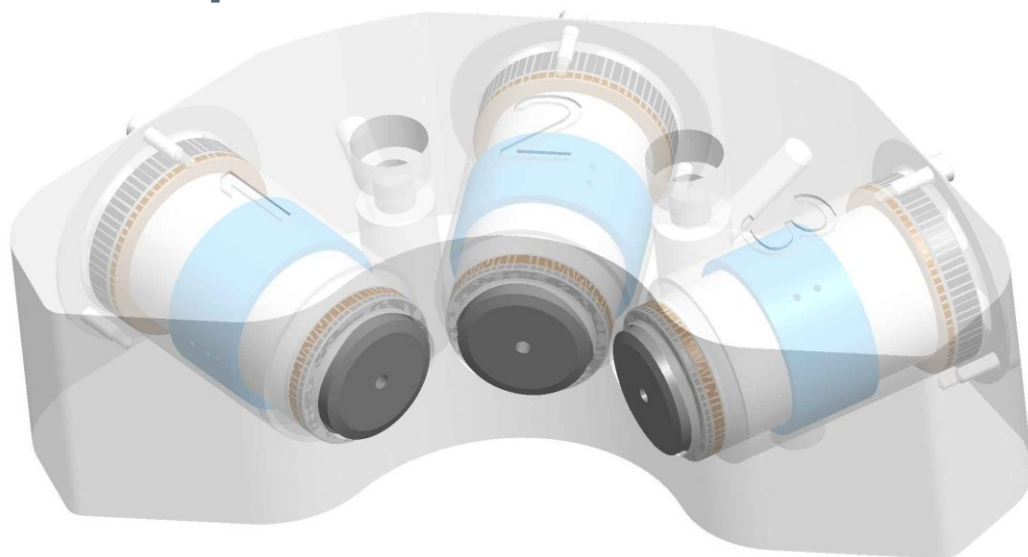
# Ion Milling- Slope Cutting FOR SEM

## Triple Ion Beam Cutter TIC3X

Used for SEM microstructure analysis  
(EDS, WDS, EBSD, CL)  
and AFM investigations

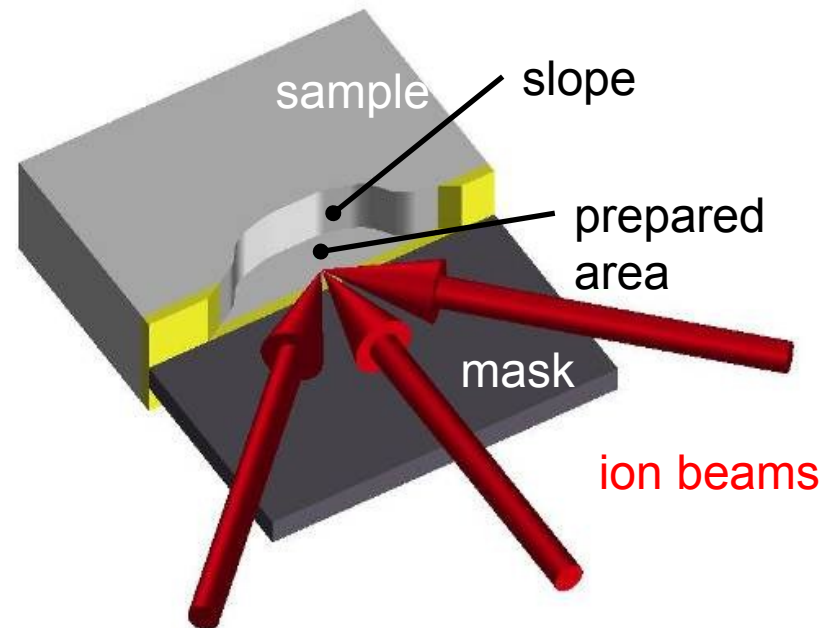


# Triple Ion Source



## Principle

- **Three ion** beams hitting the sample from different directions
- Fixed sample

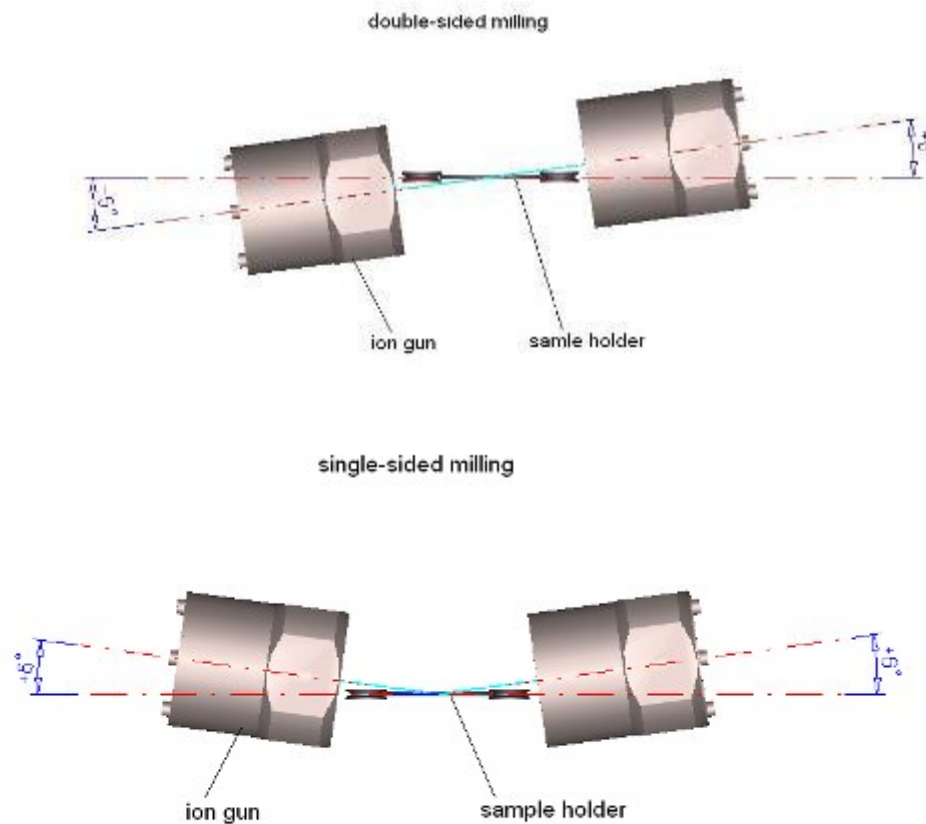


**Does not substitute a FIB on SEM,  
just because the area here is  
huge.**

**1x4mm prepared**

# Ion Milling – Only for TEM

RES 101



# Applications of the RES 101

## **TEM**

- Plan view preparation
- Cross-sectional sample preparation
- FIB Cleaning

## **SEM**

- Surface cleaning
- Polishing
- Contrast enhancement
- Ion beam slope cutting (35° and 90°)

## **LM**

*Muito obrigado pela vossa atenção!*

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